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CONFIRMATION NO. 8409

SERIAL NUMBER 10/085,753	FILING DATE 02/28/2002 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. TI-31620
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APPLICANTS

Toshihito Tsuga, Tsuchiura-shi, JAPAN;

Minoru Fube, Hayami-gun, JAPAN;

Kazutaka Nakayama, Hayami-gun, JAPAN;

** CONTINUING DATA *MK (NONE)*

** FOREIGN APPLICATIONS *MK (verified)*
JAPAN 2001-059776 03/05/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 03/27/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>[Signature]</i> <i>MK</i> Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 2
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ADDRESS
23494
TEXAS INSTRUMENTS INCORPORATED
P O BOX 655474, M/S 3999
DALLAS, TX
75265

TITLE
Method and device for removing particles on semiconductor wafers

FILING FEE RECEIVED 870	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit _____